Congress of the United States Washington, DC 20515

May 2, 2025

The Honorable Tom Cole Chairman Committee on Appropriations H-305, the Capitol Washington, DC 20515 The Honorable Rosa DeLauro Ranking Member Committee on Appropriations 1036 Longworth HOB Washington, DC 20515

Dear Chairman Cole and Ranking Member DeLauro,

I am requesting funding for the Nanoscience Device Research and Workforce Development Lab. The entity to receive funding for this project is the University of Dayton, located at 300 College Park Dayton, OH 45469. The funding would be used to purchase an Electron Beam Lithography (EBL) system. The project is a good use of taxpayer funds because it will support important research in post-foundry integration of novel materials, spur innovation in lithography, and provide students with invaluable experience that will prepare them for high-demand industry careers, including in the semiconductor region.

This project has a federal nexus because funding provided is for purposes described in section 272 of title 15, United States Code.

I certify that I have no financial interest in this project, and neither does anyone in my immediate family.

Sincerely,

Michael R. Turner

Member of Congress

Michael 1 June